

Lectures 23: Luminescence

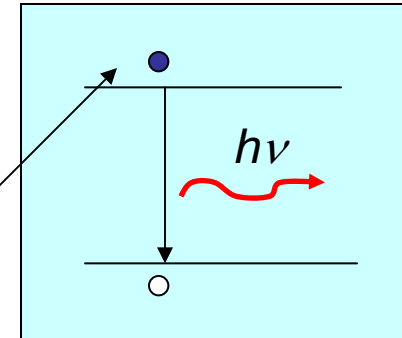
- **Luminescence** spontaneous emission in solids
- **Fluorescence** fast luminescence
electric-dipole allowed, $\tau_R \sim \text{ns}$
- **Phosphorescence** slow luminescence
electric-dipole forbidden, $\tau_R \sim \mu\text{s} - \text{ms}$
- **Electroluminescence** electrical excitation
- **Photoluminescence** optical excitation
- **Cathodoluminescence** cathode ray (e-beam) excitation

Model: Occupancy Factors

- Two level system:

$$\left(\frac{dN}{dt}\right)_{\text{radiative}} = -AN$$

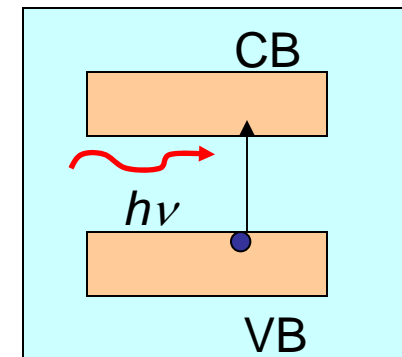
$$N(t) = N(0) \exp(-At) = N(0) \exp(-t/\tau_R)$$



Intensity is determined by the occupancy factors N

- Absorption in a solid:

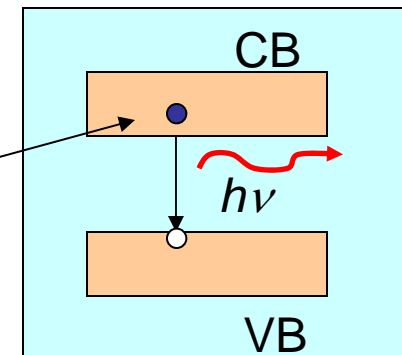
$$W_{i \rightarrow f} = \frac{2\pi}{\hbar} |M|^2 g(\hbar\omega)$$



Matrix element M and the density of states $g(h\nu)$

- Emission in a solid:

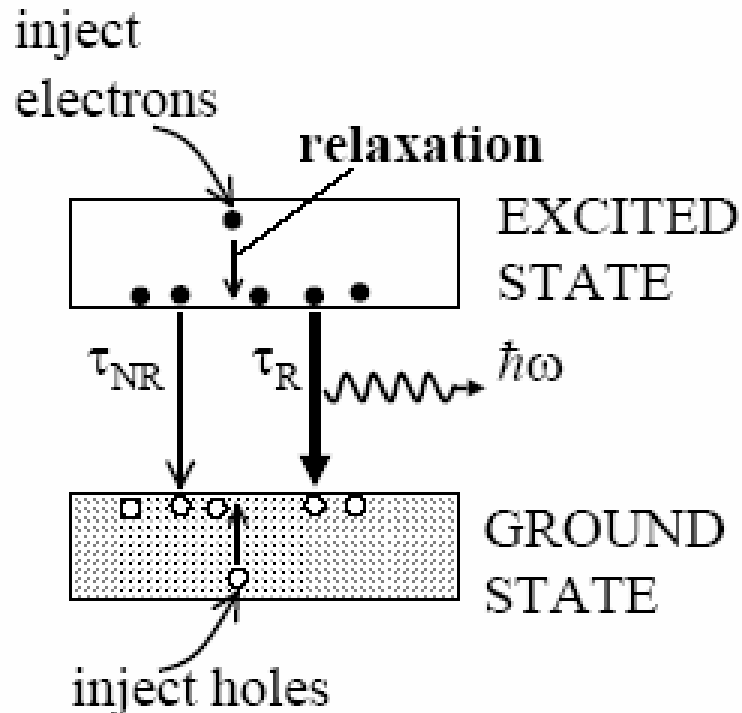
$$I(h\nu) \propto |M|^2 g(h\nu) \times \text{level_occupancy_factors}$$



Probability that the upper levels are occupied and the lower levels are empty

Model: Relaxation Path

Another difference with absorption: narrow emission band $h\nu \sim E_g$ due to fast relaxation

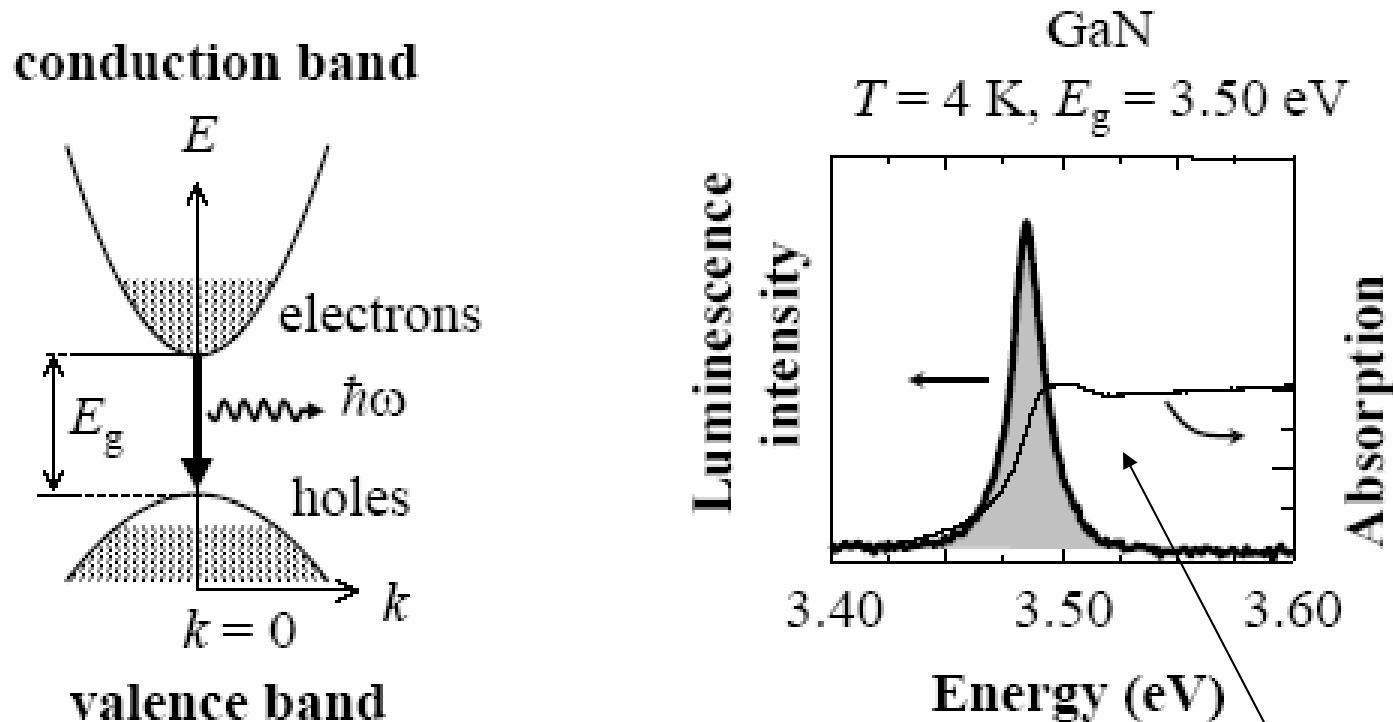


η_R = radiative quantum efficiency
= $\frac{\text{radiative transition rate}}{\text{total transition rate}}$

$$\eta_R = \frac{1}{1 + \tau_R / \tau_{NR}}$$

- Radiative transition rate determined by Einstein A -coefficient
- $\tau_R = A^{-1}$
- τ_{NR} determined by phonon population, number of traps etc

Direct Gap Materials



- Strong emission at the band gap
- most III-V and II-VI semiconductors
- linewidth $\geq k_B T$

Emission and absorption spectra are different!

- **Small radiative lifetimes $\sim 10^{-8} - 10^{-9} \text{ s}$ and high efficiency**
- **k-vector conservation – vertical transitions**

Indirect Gap Materials

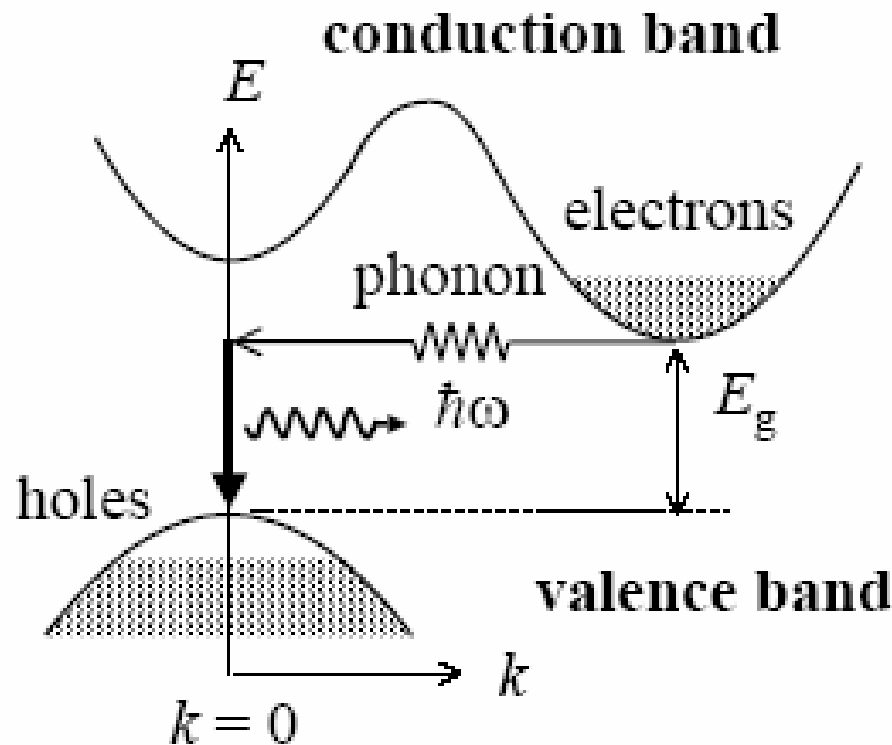
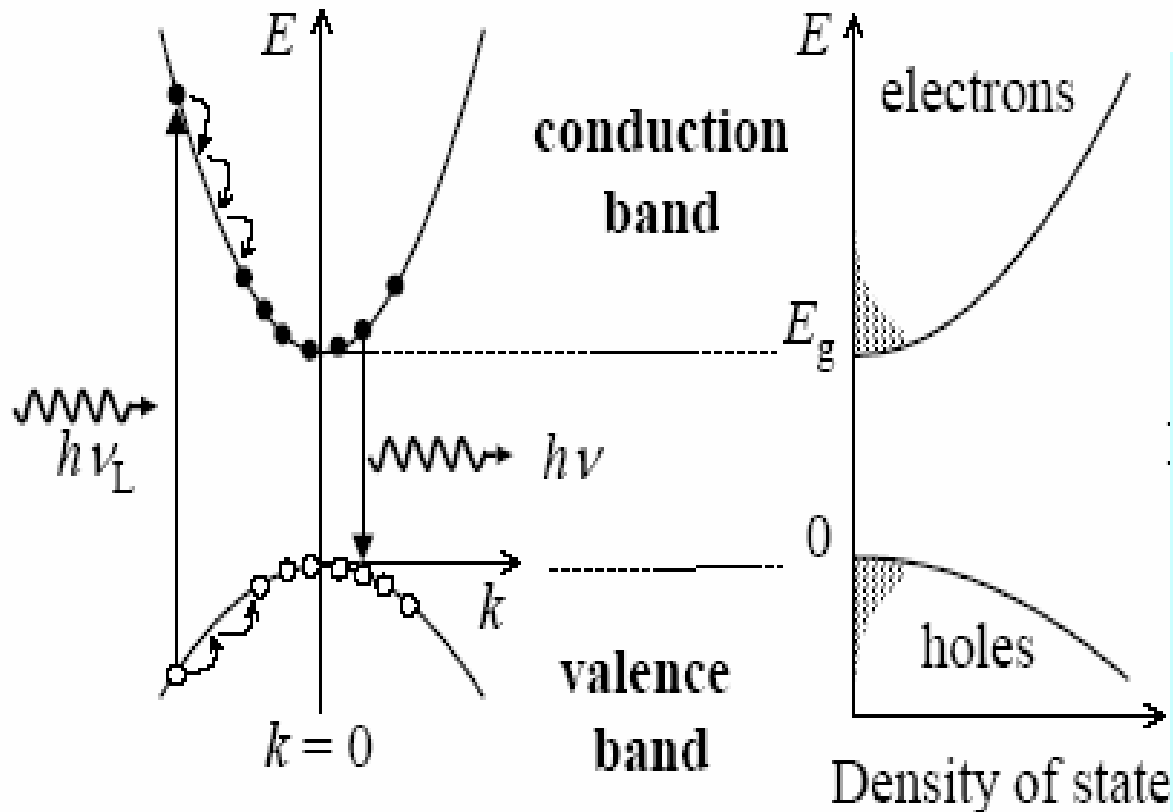


Figure 5.4

- Low emission probability (2nd order process)
- Long radiative lifetime \Rightarrow low radiative quantum efficiency
- diamond, silicon, germanium, AlAs

Photoluminescence



Hierarchy of time scales:

Excitation – fastest

Relaxation – fast (~ 100 fs or 10^{-13} s)

Thermalization – fast (~ 1 ps or 10^{-12} s)

Radiative recombination ~ 1 -10 ns or 10^{-8} - 10^{-9} s

Nonradiative recombination - slowest

- Excite using laser with photon energy $> E_g$
- electrons and holes relax to the bottom of their bands
- thermal distributions formed according to **statistical mechanics**
- emission from E_g to top of carrier distributions

Lectures 24: Luminescence (continued)

Attempting to reduce to two level system

$$N_e = \int_{E_g}^{\infty} g_c(E) f_e(E) dE \quad \longleftarrow \text{Convolution of density of states and filling factor}$$

$$g_c(E) = \frac{1}{2\pi^2} \left(\frac{2m_e^*}{\hbar^2} \right)^{\frac{3}{2}} (E - E_g)^{\frac{1}{2}} \quad \longleftarrow \text{Straightforward consequence of 3-D case}$$

$$f_e(E) = \left[\exp\left(\frac{E - E_F^c}{k_B T} \right) + 1 \right]^{-1} \quad \longleftarrow \text{Fermi-Dirac distribution at } T$$

$$N_e = \int_0^{\infty} \frac{1}{2\pi^2} \left(\frac{2m_e^*}{\hbar^2} \right)^{\frac{3}{2}} E^{\frac{1}{2}} \left[\exp\left(\frac{E - E_F^c}{k_B T} \right) + 1 \right]^{-1} dE \quad \longleftarrow \text{Different Fermi levels for electrons } (E_F^c) \text{ and holes } (E_F^h) \text{ measured from the edges of the corresponding bands}$$

$$N_h = \int_0^{\infty} \frac{1}{2\pi^2} \left(\frac{2m_h^*}{\hbar^2} \right)^{\frac{3}{2}} E^{\frac{1}{2}} \left[\exp\left(\frac{E - E_F^h}{k_B T} \right) + 1 \right]^{-1} dE$$

$$N_e = N_h$$

Classical (Boltzmann) Statistics

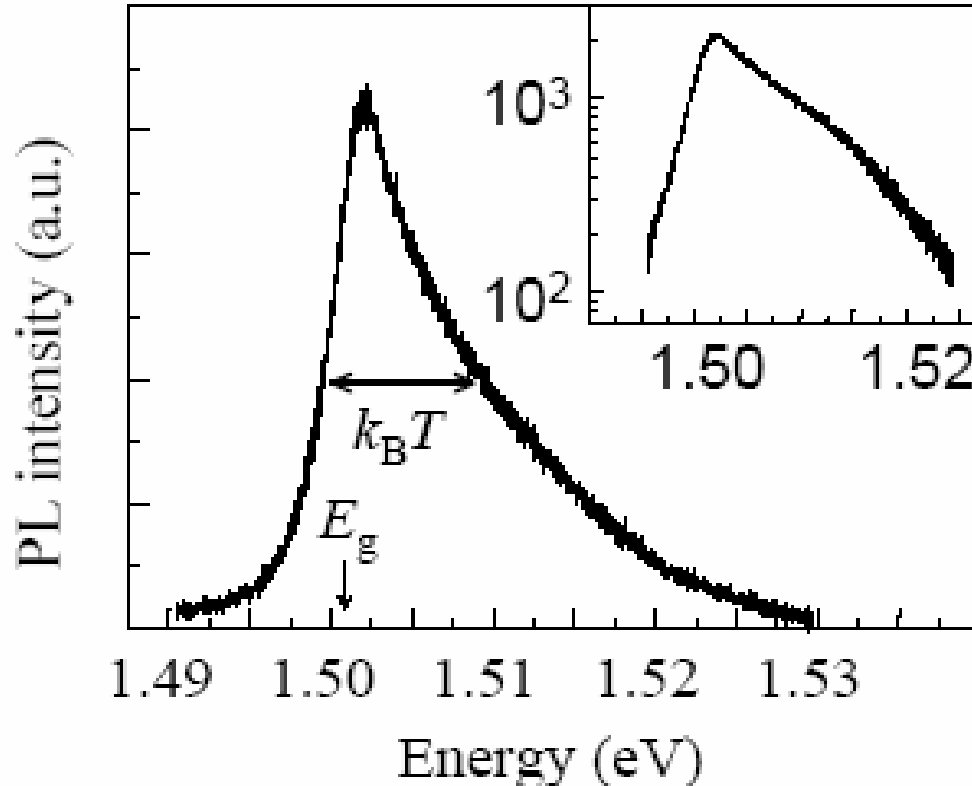


Figure 5.6

GaAs

$T = 100$ K

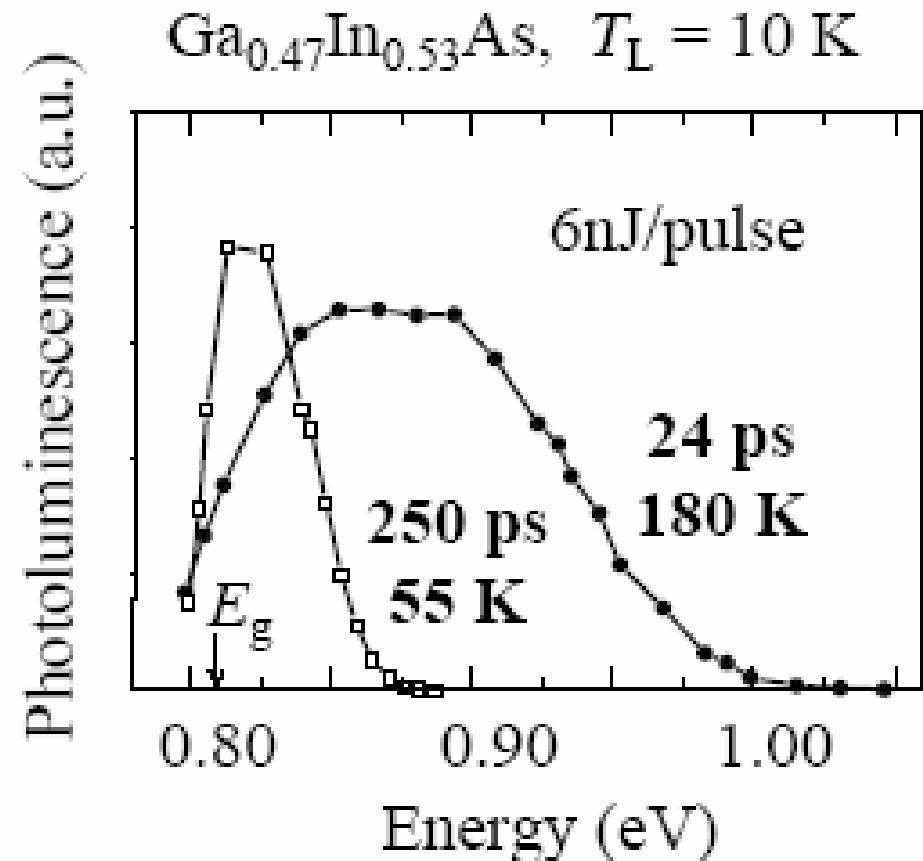
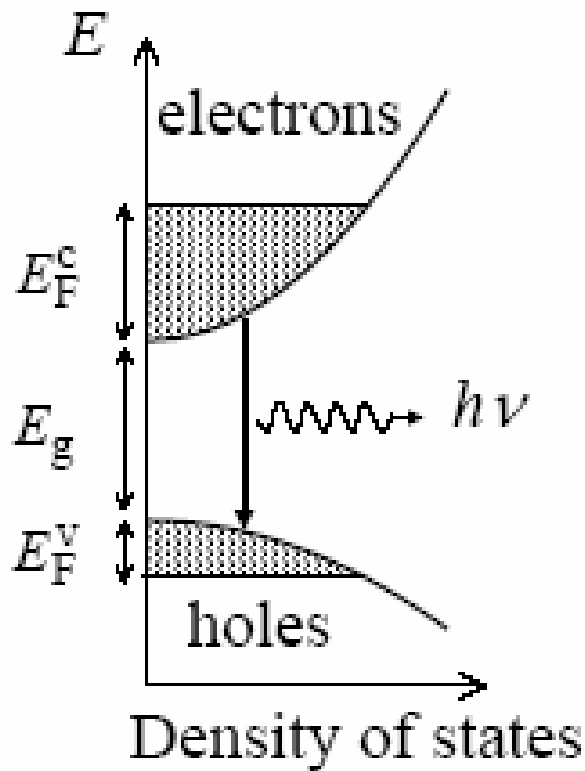
$k_B T = 8.6$ meV

$E_g = 1.501$ eV

- Boltzmann statistics: $f(E) \propto \exp(-E/k_B T)$ (**occupancy factors**)
- $I(E) \propto$ Density of states $\times f_e(E) f_h(E)$
- PL rises sharply at E_g , then decays exponentially. Linewidth $\sim k_B T$

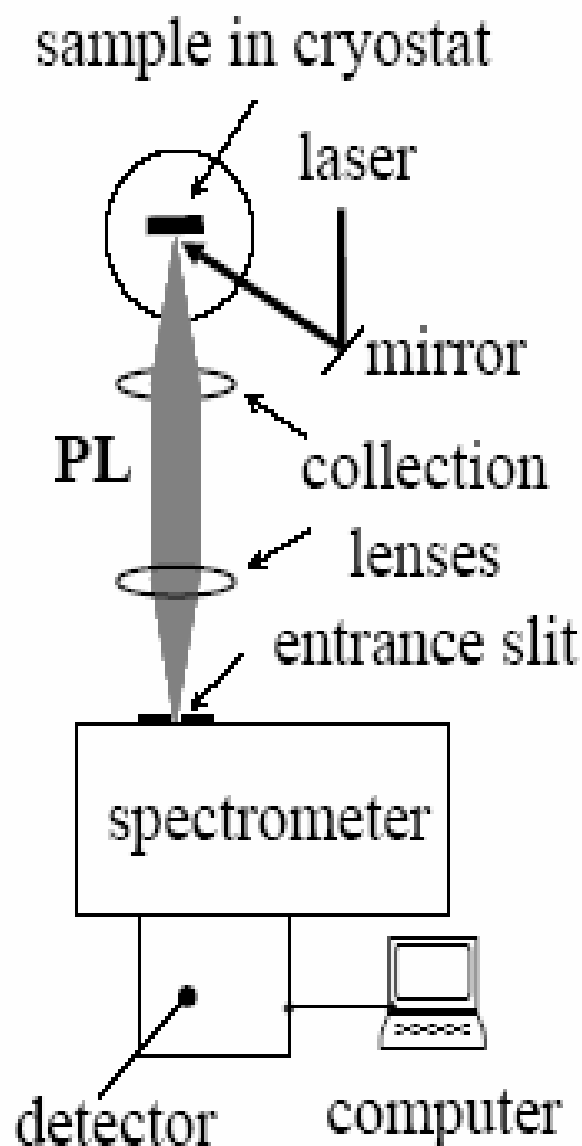
$$I(h\nu) \propto (h\nu - E_g)^{1/2} \exp\left(-\frac{h\nu - E_g}{k_B T}\right)$$

Degeneracy



- Degeneracy observed at high density and low temperatures
- Emission from E_g to $(E_g + E_F^c + E_F^v)$

Photoluminescence Spectroscopy



Photoluminescence (PL) spectroscopy

- fixed frequency laser, measure spectrum by scanning spectrometer

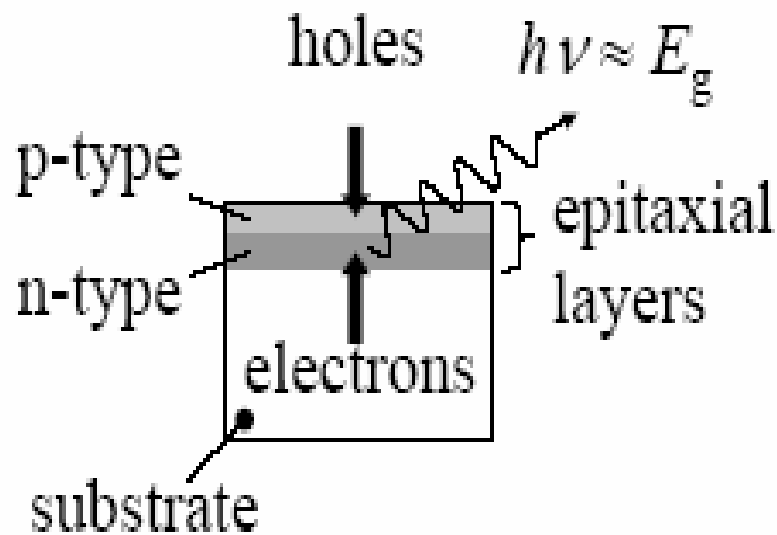
PL excitation spectroscopy (PLE)

- detect at peak emission, vary laser frequency
- effectively measures absorption

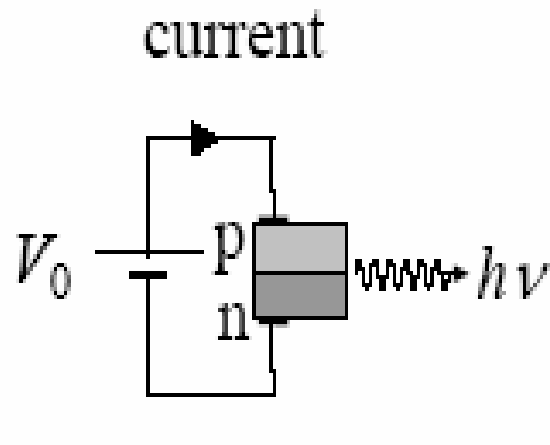
Time-resolved PL spectroscopy

- short pulse laser + fast detector
- measure lifetimes, relaxation processes

Electroluminescence



- Epitaxial growth of high purity light-emitting layers on substrate crystal
- MBE, MOCVD, LPE



- Forward-biased p-n junction
- Electrons and holes recombine at the junction
- photon energy $\sim E_g$

Lattice Matching

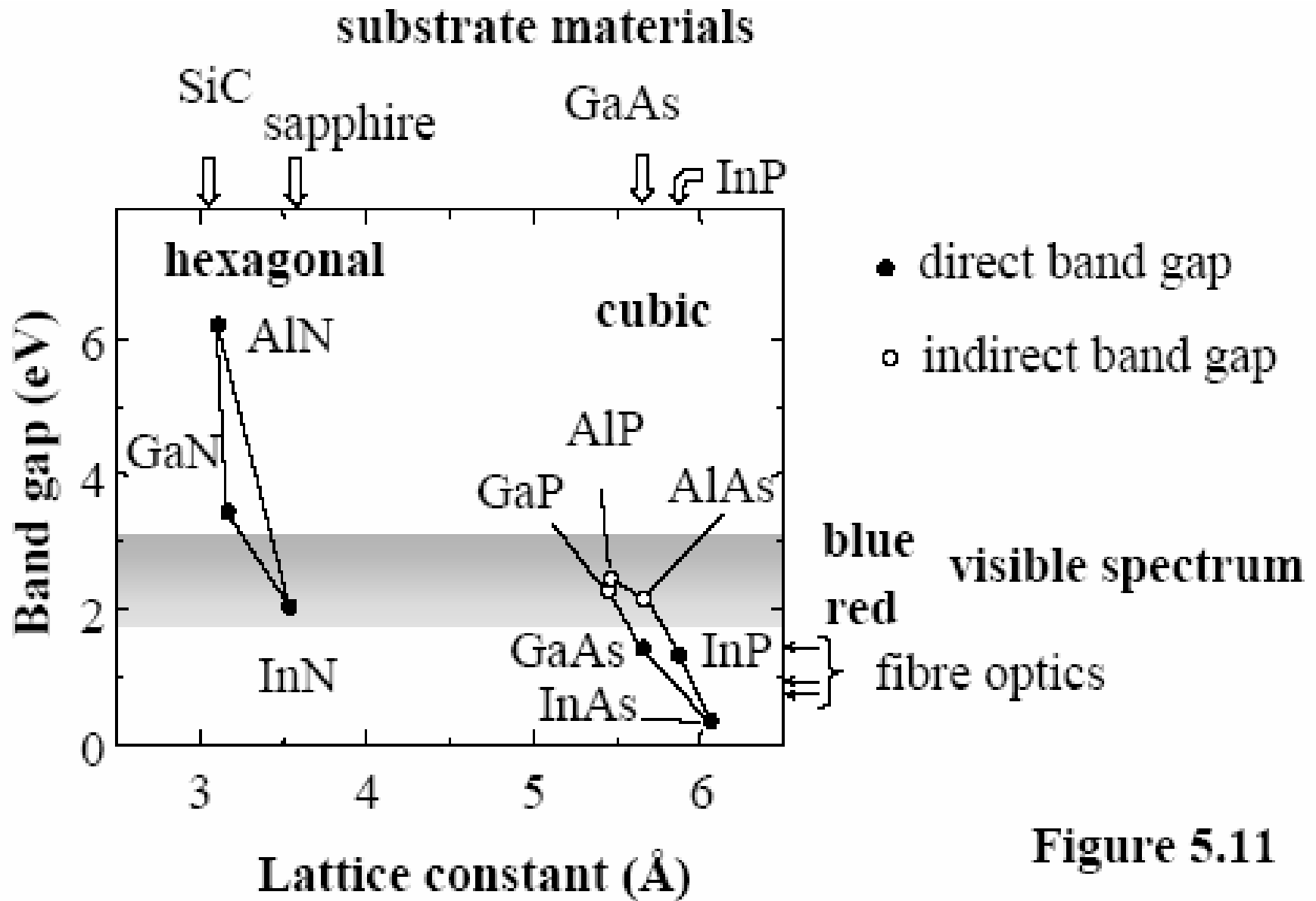
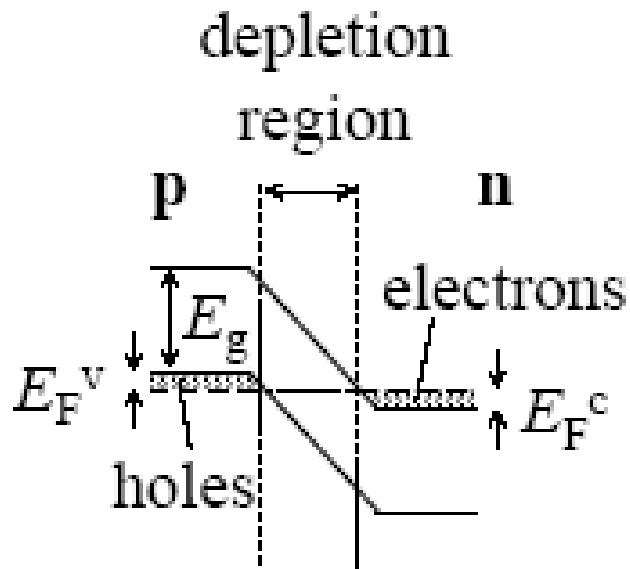


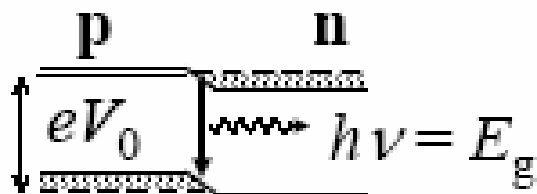
Figure 5.11

Lectures 25: Diode Lasers

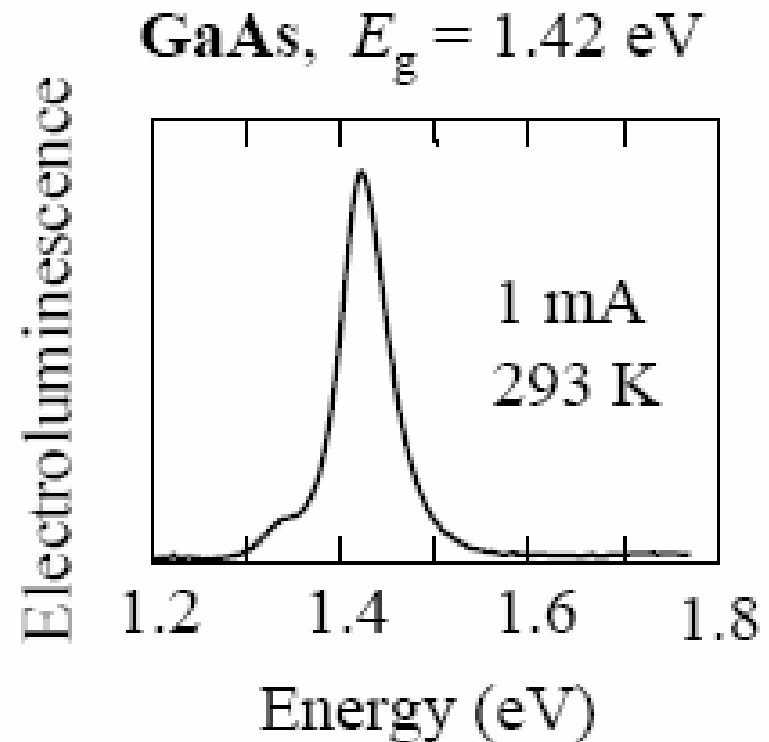
Junction Electroluminescence



(a) $V_0 = 0$

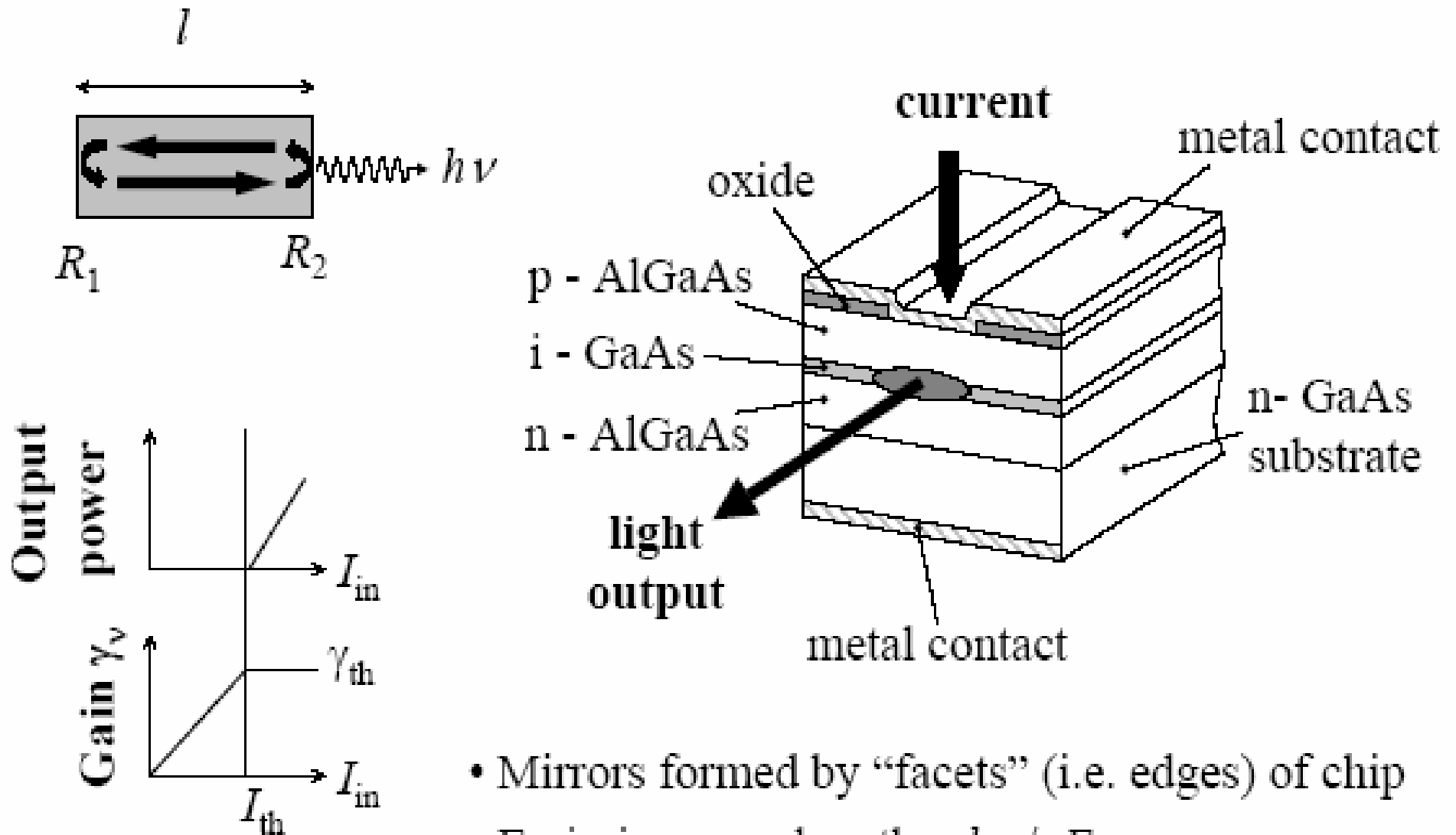


(b) $V_0 \approx +E_g/e$



- Emission at E_g
- Operating voltage $\sim E_g / e$
- Spectral width $\sim k_B T$

Diode Lasers



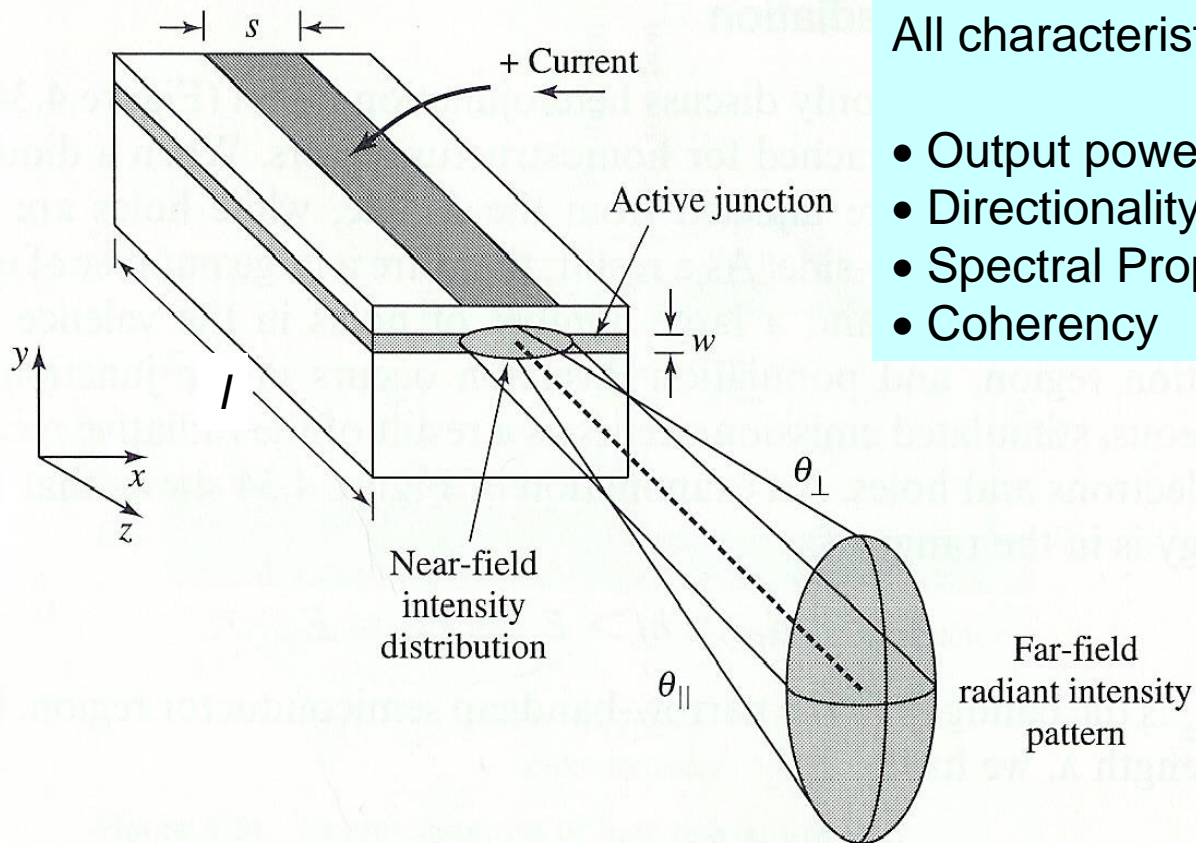
- Mirrors formed by “facets” (i.e. edges) of chip
- Emission wavelength $\sim hc / E_g$
- Linewidth determined by cavity modes

Diode Lasers

- Threshold current I_{th}
- Below the threshold – spontaneous emission
- Above the threshold – stimulated emission

All characteristics are changed at I_{th} :

- Output power
- Directionality
- Spectral Properties
- Coherency



Diode Lasers

$$m \times \frac{\lambda'}{2} = l, \text{ where } \lambda' = \lambda / n$$

$$\nu = m \times \frac{c}{2nl}$$

$$dI = +\gamma_\nu dx \times I(x)$$

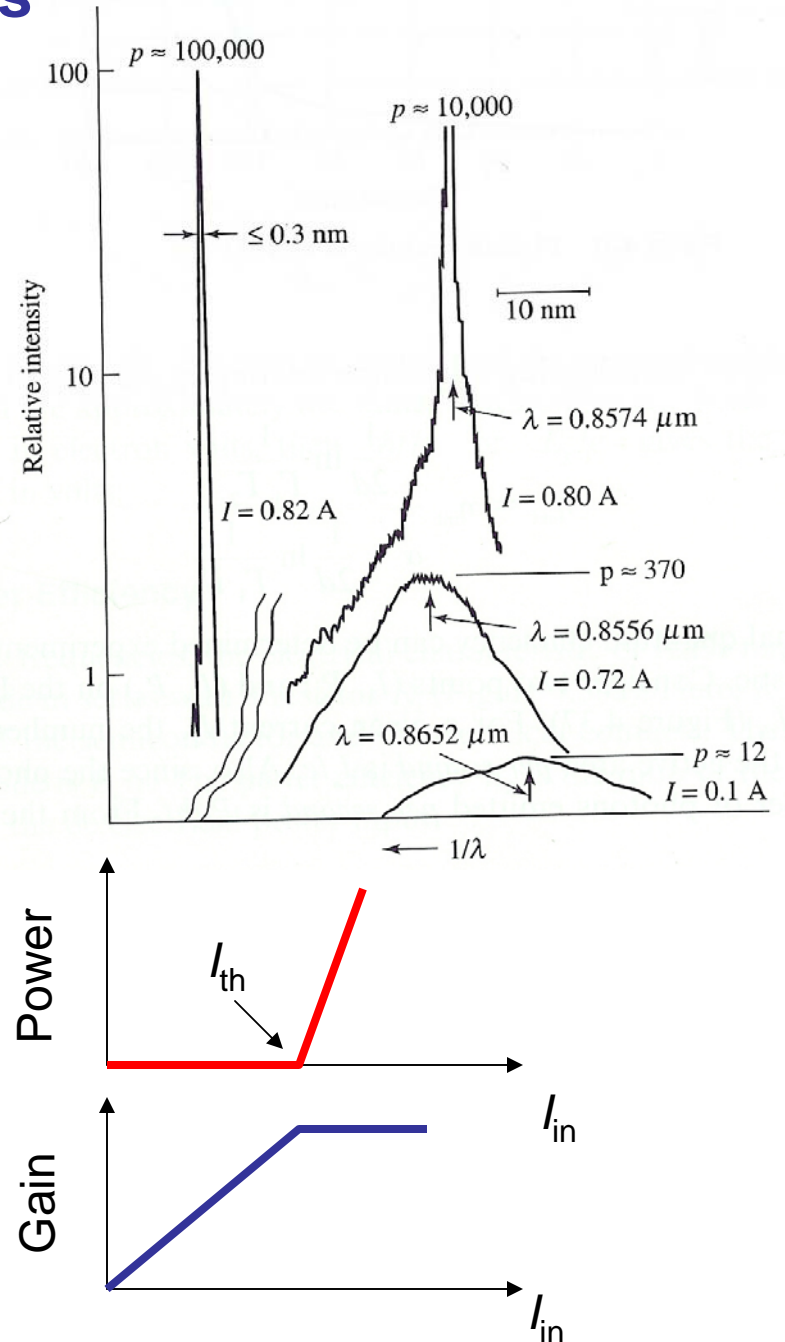
$$I(x) = I_0 e^{\gamma_\nu x}$$

$$R_1 R_2 e^{2\gamma_\nu x} e^{-2\alpha_b l} = 1$$

$$\gamma_{th} = \alpha_b - \frac{1}{2l} \ln(R_1 R_2)$$

$$P_{out} = \eta \frac{h\nu}{e} (I_{in} - I_{th})$$

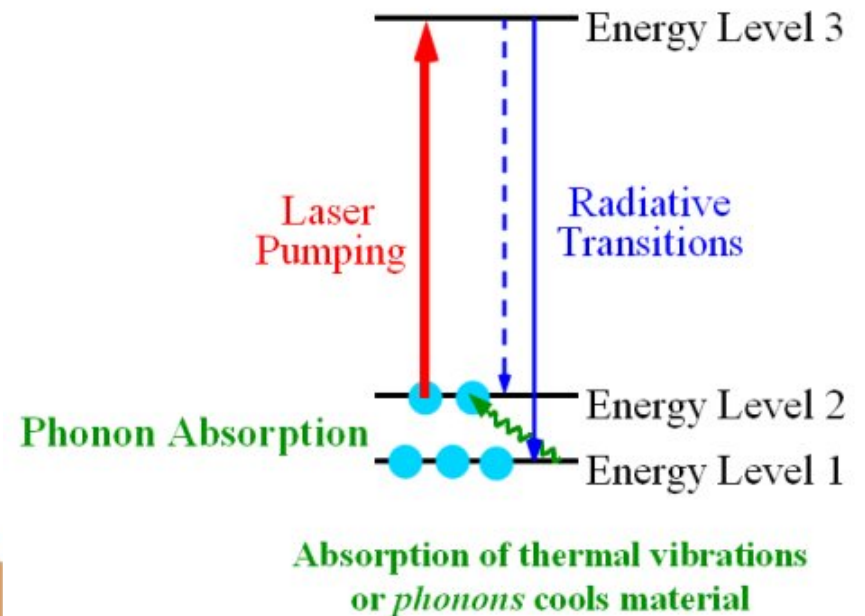
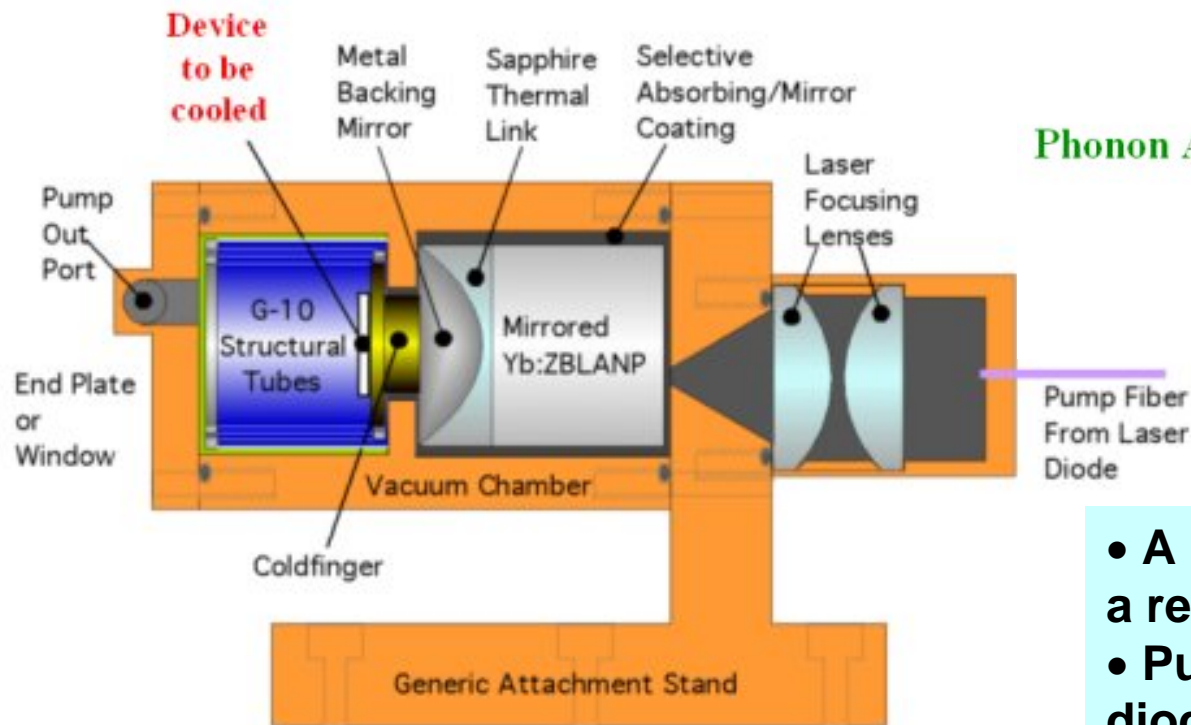
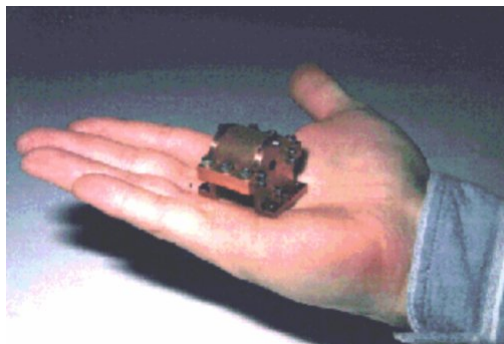
$$\text{Slope efficiency} = \frac{P_{out}}{(I_{in} - I_{th})} = \frac{\eta h\nu}{e}$$



Optical Refrigerating Breaks Record

[J. Thiede, J. Distel, S. R. Greenfield, and R. I. Epstein](#)

Applied Physics Letters **86** 154107 (2005)



- A prototype laser fridge cools to a record low temperature of 208 K
- Pumped with up to 11 W of diode-pumped Yb:YAG laser

Lectures 26-27: Quantum Confined Structures

$$\Delta p_x \sim \frac{\hbar}{\Delta x}$$

Confinement energy > thermal energy

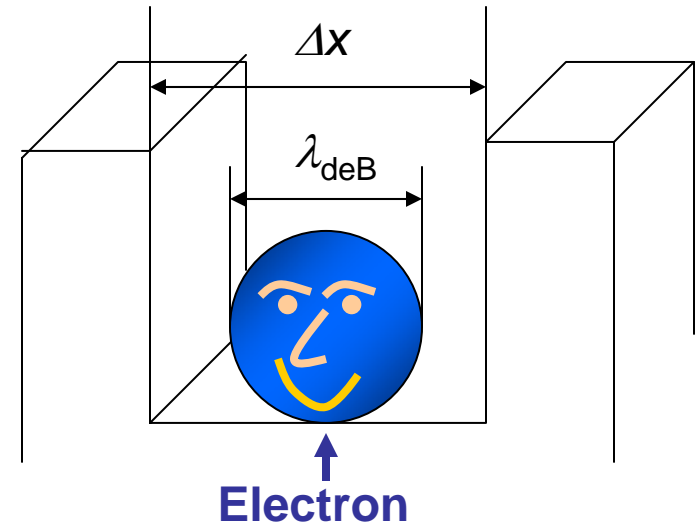
$$E_{\text{confinement}} = \frac{(\Delta p_x)^2}{2m} \sim \frac{\hbar^2}{2m(\Delta x)^2} > \frac{1}{2} k_B T$$

$$\Delta x < \sqrt{\frac{\hbar^2}{mk_B T}}$$

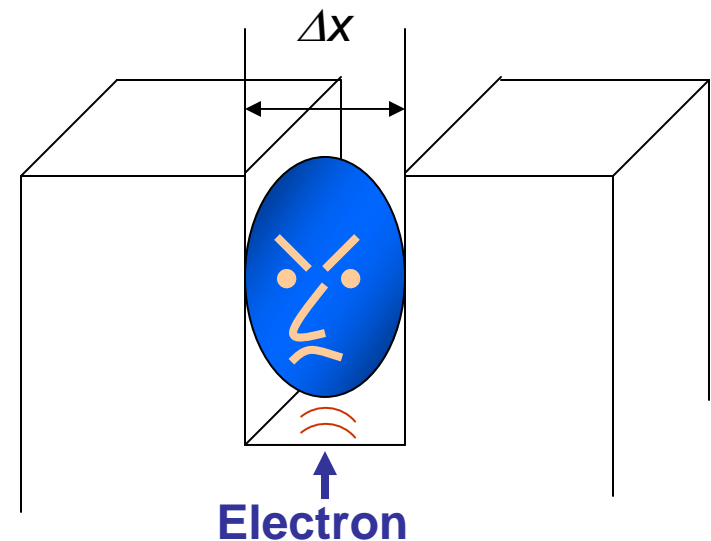
Size quantization

$$\Delta x < \lambda_{\text{deB}} \equiv p_x / h$$

No size quantization: $\Delta x > \lambda_{\text{deB}}$



Size quantization: $\Delta x < \lambda_{\text{deB}}$



To observe quantum confinement effects:

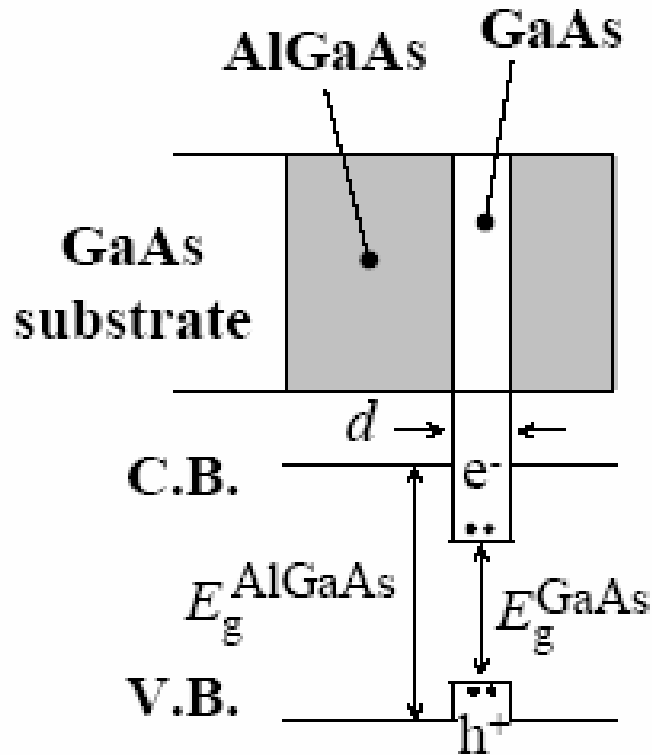
$$\Delta x < \lambda_{\text{deB}}$$

- Quantum wells (1-D) confinement (epitaxial growth)
- Quantum wires (2-D) confinement (etching of QWs or patterned substrates)
- Quantum dots (3-D) confinement (self-organized III-V dots, doped glasses)

Semiconductor Quantum Wells

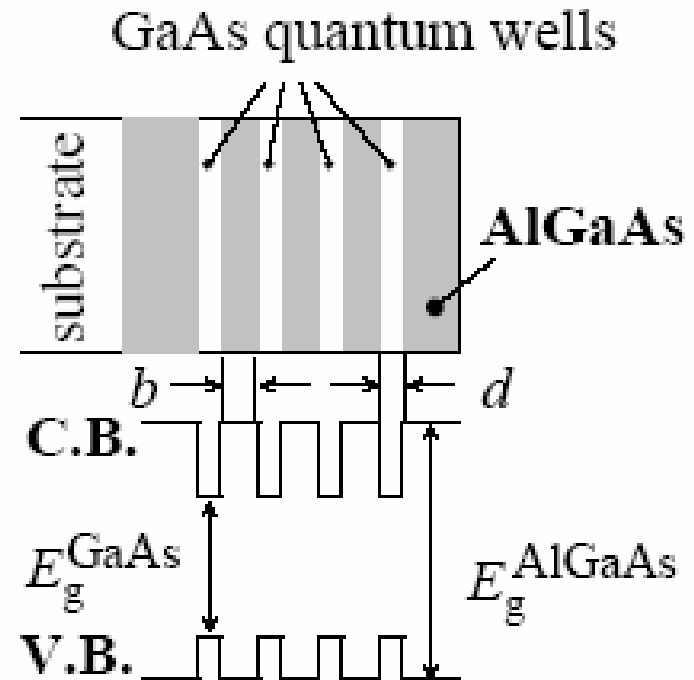
Quantization along z
Free motion along x, y

Multi-QWs: $b \geq 10\text{-}20\text{nm}$
Superlattice: $b < 10\text{nm}$



Single quantum well

crystal
growth
direction
 $\longrightarrow z$



MQW or superlattice

growth methods {

- Molecular beam epitaxy (MBE)
- Metal-organic chemical vapour deposition (MOCVD)

Separation of Variables

$$-\frac{\hbar^2}{2m} \left(\frac{\partial^2}{\partial x^2} + \frac{\partial^2}{\partial y^2} + \frac{\partial^2}{\partial z^2} \right) \psi(x, y, z) = E^{total} \psi(x, y, z) \quad \leftarrow \text{Free electron gas}$$

$$\psi(x, y, z) = \psi(x, y) \varphi(z) \quad \leftarrow \text{Motion along } x \text{ and } y \text{ is independent of } z$$

$$E^{total}(n, \mathbf{k}) = E_n + E(\mathbf{k})$$

$$\psi_{\mathbf{k}}(x, y) = \frac{1}{\sqrt{A}} e^{i\mathbf{k} \cdot \mathbf{r}} \quad \leftarrow \text{Plane waves in } xy \text{ plane}$$

$$E(\mathbf{k}) = \frac{\hbar^2 \mathbf{k}^2}{2m^*} \quad \leftarrow \textit{k}\text{-vector for motion in } xy \text{ plane}$$

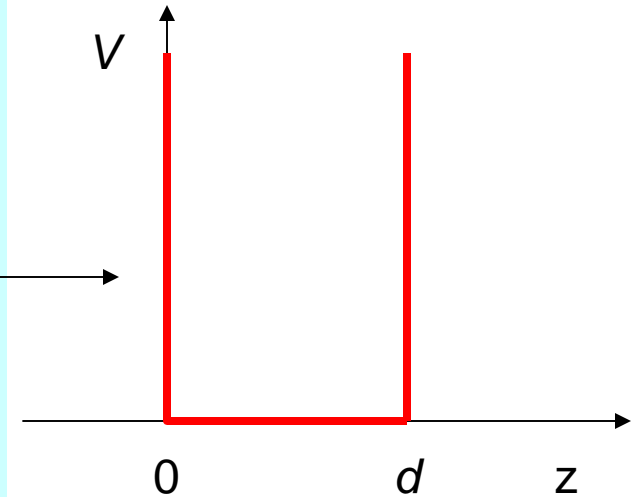
$$E^{total}(n, \mathbf{k}) = E_n + \frac{\hbar^2 \mathbf{k}^2}{2m^*}$$

Infinite Quantum Wells: 1-D problem (z)

$$-\frac{\hbar^2}{2m} \frac{d^2 \varphi(z)}{dz^2} + V(z)\varphi(z) = E\varphi(z)$$

$$\left. \begin{aligned} V(z) &= \infty \quad z < 0 \\ &= 0 \quad 0 < z < d \\ &= \infty \quad z > d \end{aligned} \right\}$$

← Potential →



$$\varphi(z) = 0 \quad z < 0$$

$$\varphi(z) = 0 \quad z > d$$

Inside the box (V(z) = 0):

$$\frac{d^2 \varphi(z)}{dz^2} + \frac{2mE}{\hbar^2} \varphi(z) = 0$$

There is no solution for E < 0:

$$\frac{d^2 \varphi(z)}{dz^2} - k^2 \varphi(z) = 0, \quad \text{where } k^2 = 2m|E|/\hbar^2$$

Infinite Quantum Wells: 1-D problem (continued)

For $E > 0$ and $k^2 = \frac{2mE}{\hbar^2}$

$$\frac{d^2 \varphi(z)}{dz^2} + k^2 \varphi(z) = 0$$

General solution:

$$\varphi(z) = A \sin kz + B \cos kz$$

Since $\varphi(0) = 0 \Rightarrow \varphi(z) = A \sin kz$

Since $\varphi(d) = 0 \Rightarrow kd = n\pi, n = 1, 2, 3, \dots$

$$k_n = n \frac{\pi}{d}$$

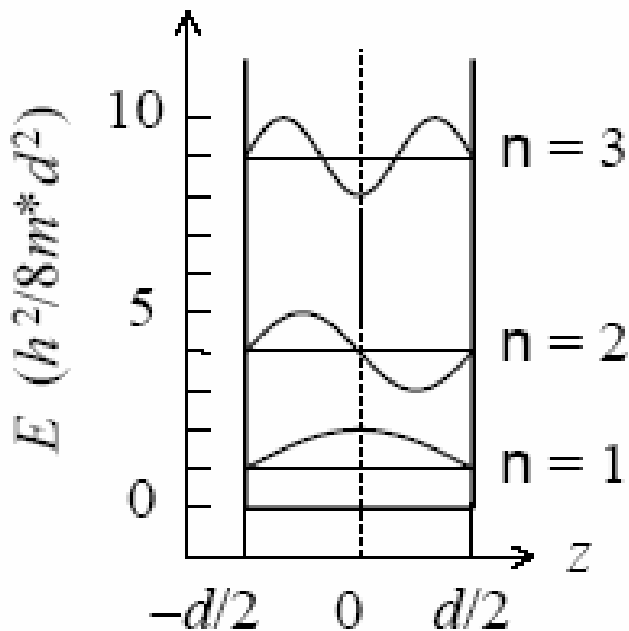
Thus:

$$E_n = \frac{\hbar^2 k_n^2}{2m} = \frac{\hbar^2 \pi^2 n^2}{2md^2}, n = 1, 2, 3, \dots$$

$$\varphi_n(z) = \sqrt{\frac{2}{d}} \sin k_n z = \sqrt{\frac{2}{d}} \sin \frac{n\pi z}{d}$$

If we select 0 in the middle of the well:

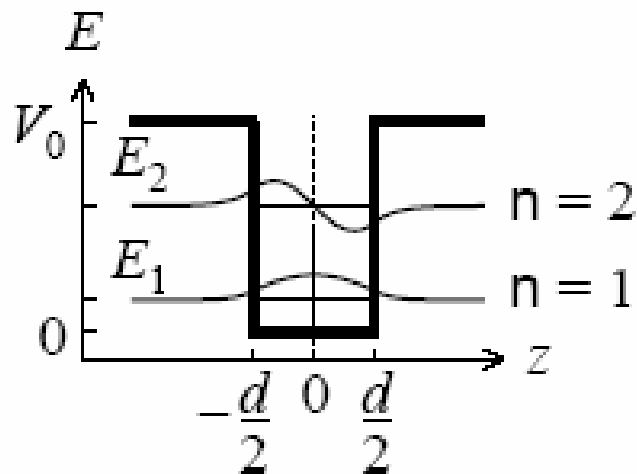
$$\varphi_n(z) = \sqrt{\frac{2}{d}} \sin k_n z \rightarrow \sqrt{\frac{2}{d}} \sin\left(k_n z + \frac{n\pi}{2}\right)$$



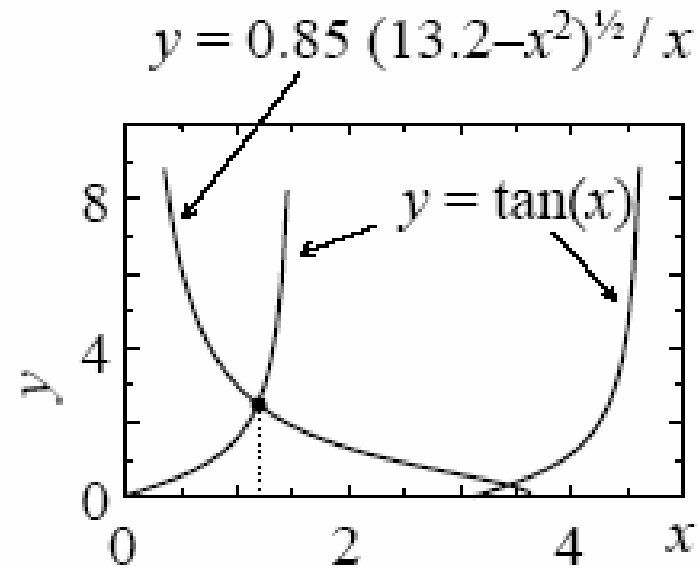
- $k_n = n\pi/d$
- $E_n = (\hbar^2\pi^2/2m^*d^2) n^2$
- $\psi_n = (2/d)^{1/2} \sin(k_n z + n\pi/2)$

- symmetry about $z = 0 \Rightarrow$ wave functions have definite **parity**
- ψ_n has $(n-1)$ nodes
- E_n depends on m^* , hence heavy and light holes split

Finite QWs



- Wave functions tunnel into the barrier
- wave function still identified by parity and number of nodes
- Confinement energy reduced compared to infinite well
- graphical solution to find E_n



Example : GaAs/AlGaAs

$$V_0 = 0.3 \text{ eV}, d = 10 \text{ nm}$$

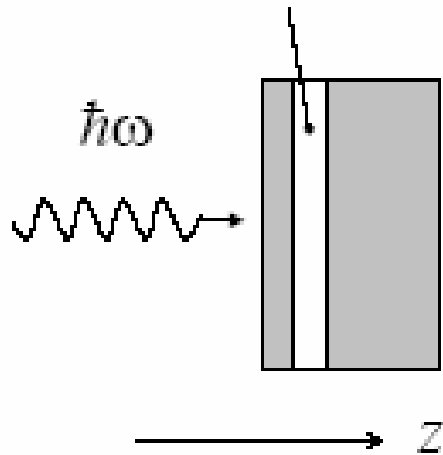
$$m_w^* = 0.067m_e, m_b^* = 0.092m_e$$

$$E_1 = 31.5 \text{ meV}$$

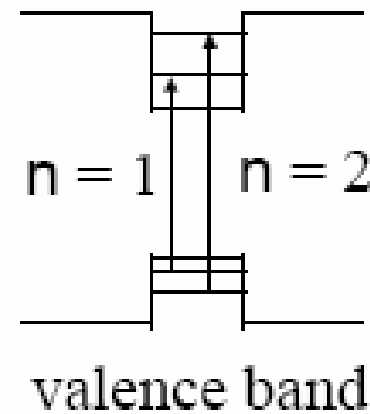
$$\text{c.f. infinite well: } E_1 = 57 \text{ meV}$$

Optical Transitions

quantum well



conduction band



- Light polarized in x,y plane for normal incidence
- Parity selection rule: $\Delta n = \text{even number}$
- Infinite well selection rule: $\Delta n = 0$

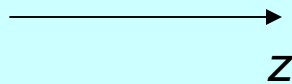
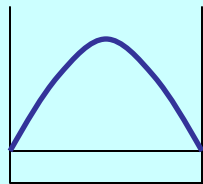
Selection Rules

$$M_{nn'} = \int_{-\infty}^{\infty} \varphi_{en'}^*(z) \varphi_{hn}(z) dz = \frac{2}{d} \int_{-d/2}^{d/2} \sin(k_n z + \frac{n\pi}{2}) \sin(k_{n'} z + \frac{n'\pi}{2}) dz$$

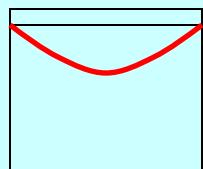
$$\int = 1 \text{ if } n = n'$$

Good spatial overlap along z between electron and hole

$n=1$



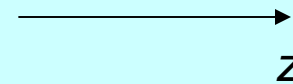
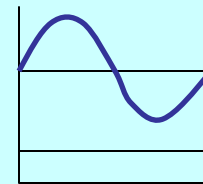
$n=1$



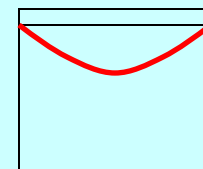
$$\int = 0 \text{ if } n \neq n'$$

Poor spatial overlap along z between electron and hole

$n=2$

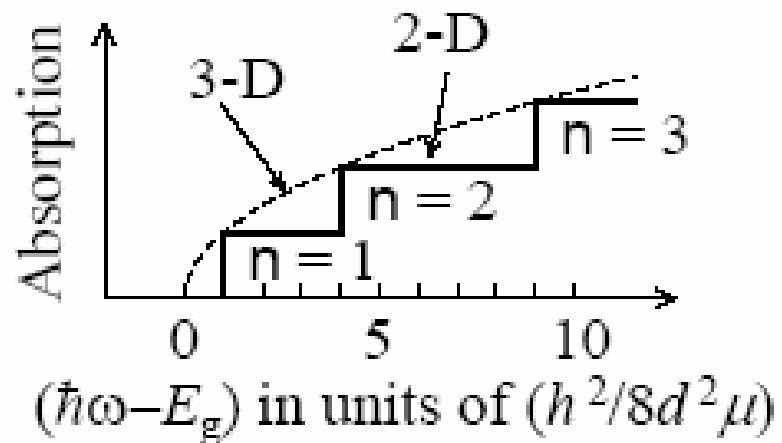
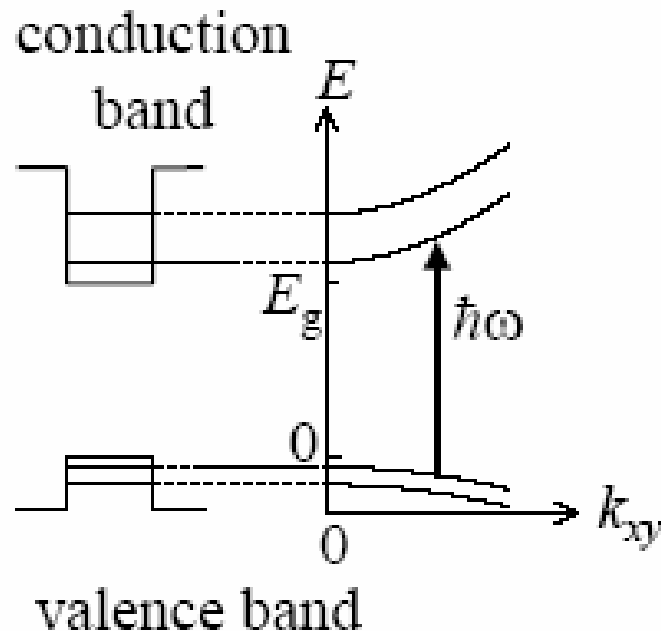


$n=1$



The selection rule $\Delta n = 0$ appears as a result of maximizing the matrix element proportional to the overlap of the electron and hole states.

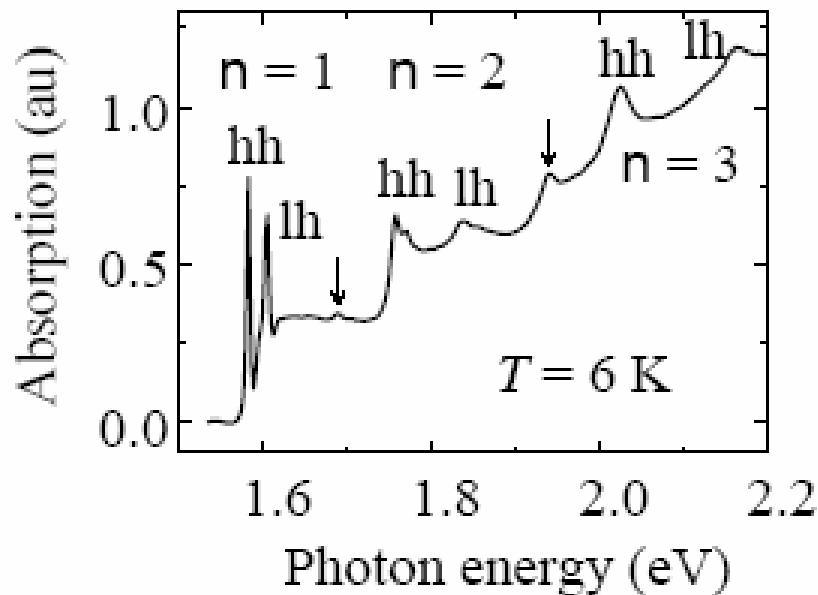
Optical Absorption



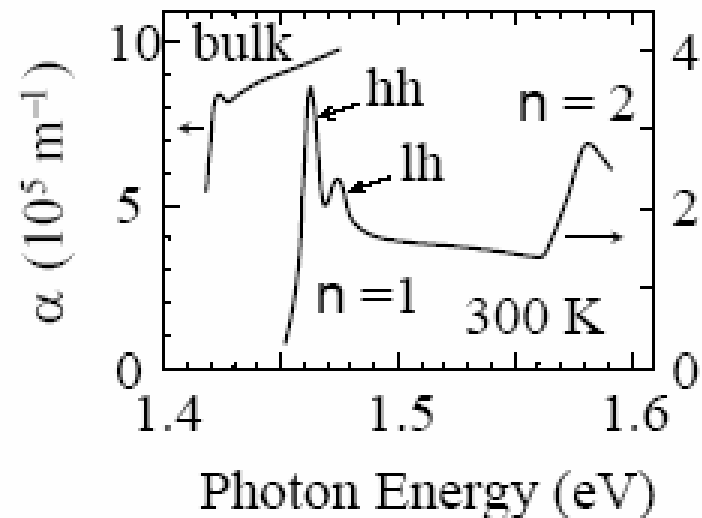
- Absorption \propto density of states
- Density of states constant in 2-D: $g_{2D}(E) = m / \pi\hbar^2$
- Thresholds whenever $\hbar\omega$ exceeds $(E_g + E_{en} + E_{hn})$
- Band edge shifts to $(E_g + E_{e1} + E_{hh1})$

GaAs Quantum Wells

GaAs/AlAs MQW, $d = 7.6$ nm



GaAs/AlGaAs MQW
 $d = 10$ nm



- Excitonic effects enhanced in quantum wells: strong at room temp
- Pure 2-D: $R_X^{2D} = 4 \times R_X^{3D}$
- Typical GaAs quantum well: $R_X \sim 10$ meV $\sim 2.5 \times R_X$ (bulk GaAs)
- Splitting of heavy and light hole transitions